



Image

Docket No.: 8733.132.20-US  
(PATENT)

AF  
(814)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Joon-Young Yang

Confirmation No.: 8761

Application No.: 09/875,197 ✓

Art Unit: 2814

Filed: June 7, 2001

Examiner: S. H. Rao

For: METHOD OF FABRICATING A THIN FILM  
TRANSISTOR

Customer No.: 30827

**SUPPLEMENTAL AMENDMENT**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Examiner's Final Office Action dated December 31, 2003 (Paper No. 12), Applicant respectfully requests that the above-identified Patent application be reconsidered in view of the remarks.

**List of the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.